Bendable build-up substrate: F-Babuls

*F-Babuls (Freely Bendable Advanced Build-up Substrate)

- under development -

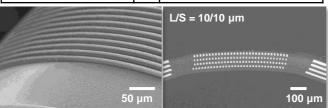
120 µm pitch?

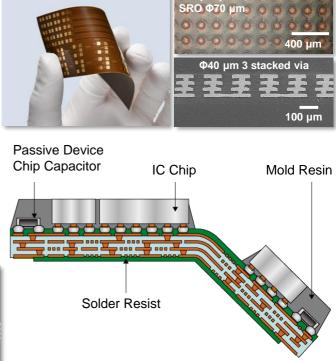
Features

- High-density bendable substrate suitable for high-speed communication and large-volume information processing
- Capable of forming fine designs that enable the mounting of various LSIs, including CPUs and GPUs
- No adhesive is used between layers, preventing degradation of transmission characteristics and increase in layer thickness.
- Bendability and low profile enable installation along the device shape.

Structure

		Specifications	
Number of Layers		Up to 5 resin layers, 4 metal layers	
Trace Design	L/S = 10/10 μm		
	Via/Land = 40/90 μm		
Dielectric Thk.	25 ~ 75 µmt		
SRO	Min. Φ70 μm, 120 μm pitch		
Round Dia.	≦ 0.5 mm		
Bendable Material	Α	For high transmission	
	В	For high elongation	
		L/S = 10/10 µm	





Reliability test

SHINKO

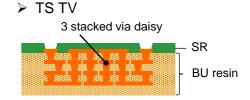
Pre-con. : JEDEC Lv. 3A

: -55 ⇔ 125 deg.C , 1000 cycles TS

HTS: 150 deg.C, 1000 hr.

b-HAST : 130 deg.C, 85 % RH, 3.5 V, 96 hr. Criteria : Change of resistance ±10 %

Reliability test	Design	Result
TS	Ф40 µm, 3 stacked via	Pass
HTS	L/S = 10/10 µm	Pass
b-HAST	L/S = 10/10 µm	Pass



> HTS, b-HAST TV $L/S = 10/10 \mu m$ serpentines



